 Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office		Attorney's Docket No. 14580-031001	Application No. 10/673,053
	Information Disclosure Statement by Applicant (Use several sheets if necessary)			
	Applicant Rainer Bruchhaus et al.			
	Filing Date September 26, 2003		Group Art Unit 2811	

U.S. Patent Documents


Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
SK	AA	2001/0007366	07/2001	Kim, et al.	—	—	
SK	AB	2002/0163058	11/2002	Chen, et al.	—	—	
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Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							

Other Documents (Include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
SK	AP	Katsuhiko Aoki, et al., "Effects of Titanium Buffer Layer on Lead-Zirconate-Titanate Crystallization Processes in Sol-Gel Deposition Technique", <i>Jpn. J. Appl. Phys.</i> , Vol. 34, Part 1, No. 1, pp. 192-195, Jan. 1995.
SK	AQ	Katsuhiko Aoki, et al., "Ferroelectric Properties of Crystalline-Oriented Lead-Zirconate-Titanates Formed by Sol-Gel Deposition Technique", <i>Jpn. J. Appl. Phys.</i> , Vol. 34, Part 1, No. 2B, pp. 746-751, Feb. 1995.
SK	AR	P. Murali, et al., "Texture control of PbTiO ₃ and Pb(Zr, Ti)O ₃ thin films with TiO ₂ seeding", <i>J. Appl. Physics</i> , 83(7):3835-3841, April 1998.
	AS	

Examiner Signature 	Date Considered 6/13/05
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	